Serial Number:		
Appn. Filed:		
Applicant(s):		
Appn. Title:		
Examiner/GAU:		
Disclosure Docume	nt Reference Letter	
	Date: 2003 September	23
Assistant Commissioner for Patents Washington, District of Columbia 20231	•	
Sir:		
A disclosure document as identified below was previously disclosure relates to the above patent application, application and referenced to the above application.		
Disclosure Document Title: <u>Process for Control of Schools of Scho</u>		Quantum Structures
Very Respectfully,  Signed Name  Nathan David Hiller  Printed Name, First Applicant  4750 Noyes 54. #215  Address of First Applicant  San Diego, CA 92109	Signed Name  Printed Name, Joint Applicant  Address of Joint Applicant	

•	·
Serial Number:	
Appn. Filed:	
Applicant(s):	
Appn. Title:	
Examiner/GAU:	·
Examiner/GAU.	
Disclosure Documen	it Reference Letter
•	Date: 2003 September 23
Assistant Commissioner for Patents Washington, District of Columbia 20231	
Sir:	
A disclosure document as identified below was previously	
disclosure relates to the above patent application, applica-	nt(s) request that this Disclosure Document be retained
and referenced to the above application.	
Process tor Co	nverting Bulk Semiconductors into
Disclosure Document Title: Supper lattice,	Quantum Wells, Wire, + Dot Structures
Disclosure Document Number: 531741	
Disclosure Document Number:	21.2003
Disclosure Document Filing Date:	
	ı
Very Respectfully,	•
7/4/2	
I have	Signed Name
Signed Name	Signed Name
Nathan David Hiller Printed Name, First Applicant	Printed Name, Joint Applicant
4750 Noyes 57. #215 Address of First Applicant	Address of Joint Applicant
San Diego, CA 92109	

Serial Number:	
Appn. Filed:	
Applicant(s):	
Appn. Title:	•
Examiner/GAU:	•
	•
Disclosure Document Re	ference Letter
	Date: 2003 September 23
Assistant Commissioner for Patents Washington, District of Columbia 20231	
Sir:	
A disclosure document as identified below was previously filed in disclosure relates to the above patent application, applicant(s) reand referenced to the above application.  Spatially Periodically Disclosure Document Title: Diffusion by Disclosure Document Number: 532668  Disclosure Document Filing Date: June 09	· ·
Nathan David Hiller Printed Name, First Applicant  4750 Noyes St. #215	Name, Joint Applicant as of Joint Applicant

0. 1.135 1
Serial Number:
Appn. Filed:
Applicant(s):
Appn. Title:
Examiner/GAU:
Disclosure Document Reference Letter
Date: 2003 September 23
Assistant Commissioner for Patents Washington, District of Columbia 20231
Sir:
A disclosure document as identified below was previously filed in the Patent and Trademark Office. As this disclosure relates to the above patent application, applicant(s) request that this Disclosure Document be retained and referenced to the above application.  Method of Forming Reviodic Potential Structures.  Disclosure Document Title: in Bulk Materials Using Standing Electro magnetic Disclosure Document Number: 53799/  Disclosure Document Filing Date: Sep. 08, 2003
Very Respectfolly,  Signed Name  Signed Name  Signed Name  Printed Name, First Applicant  Printed Name, Joint Applicant